

AMENDMENT UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE
DO NOT ENTER: /MWS/
GROUP 2891
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q79277

Kazuyuki KUWADA, et al.

Appln. No.: 10/752,700

Group Art Unit: 2891

Confirmation No.: 5921

Examiner: Matthew W. Such

Filed: January 8, 2004

For: SEMICONDUCTOR DEVICE AND PROCESS FOR PRODUCING SEMICONDUCTOR
DEVICE

AMENDMENT UNDER 37 C.F.R. § 1.116

MAIL STOP AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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Sir:

In response to the Office Action dated May 13, 2009, please amend the above-identified application as follows on the accompanying pages.

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